



Attorney Docket: 622/48561
PATENT

GA 1753

THE UNITED STATES PATENT AND TRADEMARK OFFICE

A
12/10/02

Applicant: MARTIN DUBS ET AL.
Serial No.: 09/484,421 Group Art Unit: 1753
Filed: JANUARY 18, 2000 Examiner: CANTELMO, G
Title: SPUTTER CHAMBER AS WELL AS VACUUM TRANSPORT
CHAMBER AND VACUUM HANDLING APPARATUS WITH
SUCH CHAMBERS

REPLY UNDER 37 CFR § 1.111

Commissioner for Patents
Washington, D.C. 20231

RECEIVED
DEC 19 2001
TC 1700

Sir:

The following is responsive to the Office Action mailed on or about June 14, 2001.

IN THE DRAWINGS:

Formal drawings addressing the objections (except as specifically traversed) in paragraphs 5, 6 and 7 of said Office Action will be addressed when the application is allowed as suggested by the Examiner.

A separate letter requesting drawing change approval for Fig. 3 is attached.

IN THE SUBSTITUTE SPECIFICATION:

A new Substitute Specification is submitted herewith along with a bracketed and underlined version. No new matter has been added.

IN THE CLAIMS: